

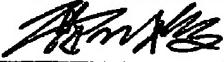
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Certificate of Facsimile Transmission

I hereby certify that the attached PTO form 1449 (3 pages) with cited references (13 pages), Information Disclosure Statement (1 page) are submitted to the U.S. Patent and Trademark Office via facsimile number 703-872-9306 on the date shown below. (Total 17 pages).


 Li Mei Vermilya

Date: April 1, 2005

 PATENT APPLICATION
 Docket No.: 9898-332
 Client Ref. No.: SS-18797-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cheol-Ju YUN

Serial No.: 10/774,081 Examiner: Lynne Ann Gurley

Confirmation No.: 7130

Filed: February 5, 2004 Group Art Unit: 2812

For: SEMICONDUCTOR DEVICE AND METHOD FOR FORMING
SAME USING MULTI-LAYERED HARD MASK
 Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450
INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- under 37 CFR 1.97 (b); or
 (Within three months of filing national application; or date of entry of International application; or before mailing date of first office action on the merits; or before the mailing of a first Office Action after the filing of a request for continued examination under §1.114; whichever occurs last)
- under 37 CFR 1.97 (c) together with either a:
 Statement under 37 CFR 1.97 (e), or
 a \$180 fee under 37 CFR 1.17 (p); or
 (After mailing of first Office Action, but prior to Notice of Allowance or Final Office Action)
- under 37 CFR 1.97 (d) together with:
 Statement under 37 CFR 1.97 (e), and
 a \$180.00 fee set forth in 37 CFR 1.17 (p).

(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

Customer No. 20575

Respectfully submitted,

MARGER JOHNSON & McCOLLUM, P.C.


Todd J. Iverson
Reg. No. 53,057

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PATENT APPLICATION

Atty. Docket No.: 9898-332 Serial No. 10/774,081
 Applicant: Cheol-Ju YUN
 Filing Date: February 5, 2004 Group: 2812

**INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)****U.S. PATENT DOCUMENTS**

<u>Exam</u>	<u>Init</u>	<u>Ref</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub Class</u>
—	—	—	6,268,287	Jul. 31, 01	Young et al.		

FOREIGN PATENT DOCUMENTS

<u>Exam</u>	<u>Init</u>	<u>Ref</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country</u>	<u>Name</u>
—	—	—	2002-0046778	Jun. 21, 02	Korea	KWANG, et al.
—	—	—	2004-0061856	Jul. 7, 04	Korea	Su-Ok JUNG

OTHER DOCUMENTS

<u>Exam</u>	<u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
—	—	—	English language abstract of Korean Publication No. 2002-0046778
—	—	—	English language abstract of Korean Publication No. 2004-0061856

Examiner: _____

Date Considered: _____

APR 01 2005

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Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

STATEMENT ON FILING INFORMATION DISCLOSURE STATEMENT
 (37 CFR 1.97(e))

I, Todd J. Iverson, the person signing below state that:
 each item of information contained in the Information Disclosure Statement submitted
 herewith was first cited in a communication from a foreign patent office in a counterpart
 foreign application not more than three months prior to the filing of this Statement

no information contained in the Information Disclosure Statement was cited in a
 communication from a foreign patent office in a counterpart foreign application and, to
 the knowledge of the person signing this Statement after making reasonable inquiry, was
 known to any individual designated in § 1.56(c) more than three months prior to the filing
 of the Statement.

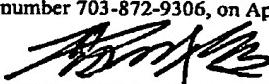
Applicant respectfully requests consideration of the accompanying Information
 Disclosure Statement.

The person making this Statement is the attorney who signs below on the basis of the
 information in the attorney's file.

Respectfully submitted,
 MARGER JOHNSON & McCOLLUM, P.C.


 Todd J. Iverson, Reg. No. 53,057

I hereby certify that this correspondence is being
 transmitted to the U.S. Patent and Trademark Office
 via facsimile number 703-872-9306, on April 1, 2005.



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